

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/797,998	LIN, SHI-TRON
Examiner	Art Unit	
Stacy A. Whitmore	2825	

SEARCHED

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
716	10,12, 19	7/27/2006	SW